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PATENT APPLICATION

09/997,786

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Application of: Duncan M. Walker, et al.  
Serial No.: 09/997,786  
Filing Date: November 30, 2001  
Confirmation No. 4798  
Title: SYSTEM AND METHOD FOR DETECTING  
QUIESCENT CURRENT IN AN INTEGRATED  
CIRCUIT

Assistant Commissioner for Patents  
Washington, D.C. 20231

I hereby certify that this communication is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231.

*R. Cisneros de Chiquero*

Date: March 25, 2002

Dear Sir:

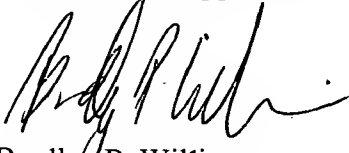
### INFORMATION DISCLOSURE STATEMENT

Applicants respectfully request, pursuant to 37 C.F.R. §§ 1.56, 1.97 and 1.98, that the references listed on the attached PTO-1449 form be considered and cited in the examination of the above-identified patent application. Copies of these references are enclosed for the convenience of the Examiner. Furthermore, pursuant to 37 C.F.R. § 1.97(g) and (h), no representation is made that a search has been made or that these references qualify as prior art or that these references are material to the patentability of the present application.

This Information Disclosure Statement is being submitted before an Office Action on the merits, and therefore, pursuant to 37 C.F.R. § 1.97(b), no fee is believed due. However, the Commissioner is hereby authorized to charge any required fee to Deposit Account No. 02-0384 of Baker Botts L.L.P.

Respectfully submitted,

BAKER BOTTS L.L.P.  
Attorneys for Applicants



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Date: March 25, 2002



PTO-1449		Application No. 09/997,786		Applicant(s) Duncan M. Walker, et al.			
Information Disclosure Citation in an Application		Docket Number 017575.0551		Group Art Unit		Filing Date 11/30/2001	
<b>U.S. PATENT DOCUMENTS</b>							
		<b>DOCUMENT NO.</b>	<b>DATE</b>	<b>NAME</b>	<b>CLASS</b>	<b>SUBCLASS</b>	<b>FILING DATE</b>
	<b>A</b>	4,677,380	06/30/1987	Popovic et al	324	252	06/07/1983
	<b>B</b>	5,570,034	10/29/1996	Needham et al.	324	763	12/29/1994
<b>FOREIGN PATENT DOCUMENTS</b>							
		<b>DOCUMENT NO.</b>	<b>DATE</b>	<b>COUNTRY</b>	<b>CLASS</b>	<b>SUBCLASS</b>	<b>TRANSLATION</b>
	<b>C</b>						<b>YES</b> <b>NO</b>
	<b>D</b>						
<b>NON-PATENT DOCUMENTS</b>							
		<b>DOCUMENT (Including Author, Title, Source, and Pertinent Pages)</b>					<b>DATE</b>
	<b>E</b>	J. Lin and M. Milkovic, "Performance Limitations of Stochastic Sensors," <u>Midwest Symposium on Circuits and Systems</u>					Aug. 1992
	<b>F</b>	P. Nigh, W. Needham, K. Butler, P. Maxwell and R. Aitken, "An Experimental Study Comparing the Relative Effectiveness of Functional, Scan, IDDq and Delay-fault Testing, <u>IEEE Int'l ASIC Conference</u>					1996
	<b>G</b>	J. Rius and J. Figueras, "Dynamic Characterization of Built-In Current Sensors Based on PN Junctions: Analysis and Experiments," <u>Journal of Electronic Testing: Theory and Applications</u> , Vol. 9, No. 3					Dec. 1996
	<b>H</b>	J.M. Soden and C.F Hawkins, "IDDQ Testing and Defect Classes - A Tutorial," <u>IEEE Custom Integrated Circuits Conference</u>					1995
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	<b>J</b>	T.R. Henry and T. Soo, "Burn-In Elimination of a High Volume Microprocessor Using IDDQ," <u>IEEE Int'l Test Conference</u>					1996
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	<b>L</b>	D.M.H. Walker, "Requirements for Practical IDDQ Testing of Deep Submicron Circuits," <u>IEEE Int'l Workshop on Defect Based Training</u>					April 2000
	<b>M</b>	P.C. Maxwell, R.C. Aitken, K.R. Kollitz and A.C. Brown, "IDDQ and AC Scan: The War Against Unmodelled Defects," <u>IEEE Int'l Test Conference</u>					1996
	<b>N</b>	T. Meneghini and D. Josephson, "IDDQ Testing of a 180MHz HP PA-RISC Microprocessor with Redundancy Programmed Caches," <u>IEEE Int'l Workshop on IDDQ Testing</u>					Nov. 1997
	<b>O</b>	P. Nigh, D. Vallett, A. Patel and J. Wright, "Failure Analysis of Timing and IDDq-only Failures from the SEMATECH Test Methods Experiment," <u>IEEE Int'l Test Conference</u>					1998
	<b>P</b>	T.A. Unni and D.M.H. Walker, "Model-Based IDDQ Pass/Fail Limit Setting," <u>IEEE Int'l Workshop on IDDQ Testing</u>					Nov. 1998
	<b>Q</b>	A.E. Gattiker and W. Maly, "Current Signatures: Application," <u>IEEE Int'l Test Conference</u>					1997
	<b>R</b>	C. Thibeault, "On the Comparison of $\Delta I_{DDQ}$ and $I_{DDQ}$ Testing," <u>IEEE VLSI Test Symposium</u>					April 1999
<b>EXAMINER</b>				<b>DATE CONSIDERED</b>			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.							

U.S. Patent and Trademark Office



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	A						
	B						
<b>FOREIGN PATENT DOCUMENTS</b>							
		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
	C						
<b>NON-PATENT DOCUMENTS</b>							
		DOCUMENT (Including Author, Title, Source, and Pertinent Pages)					DATE
	D	C. Thibeault, "An Histogram Based Procedure for Current Testing of Active Defects," <u>IEEE Int'l Test Conference</u>					1999
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	I	S. Hentschke, S. Rohrer and N. Reifschneider, "Stochastic Magnetic Field Micro-Sensor," <u>IEEE Int'l ASIC Conference</u>					1999
	J	J.P.M. van Lammeren, " $I_{CCQ}$ : a Test Method for Analogue VLSI Based on Current Monitoring," <u>IEEE Int'l Workshop on IDDQ Testing</u>					1997
	K	K. Nose and T. Sakurai, "Micro IDDQ Test Using Lorentz Force MOSFET's," <u>IEEE Symposium on VLSI Technology</u>					1999
	L	F.J. Kub and C.S. Scott, "Multiple-Gate Split-Drain MOSFET Magnetic-Field Sensing Device and Amplifier," <u>International Electron Devices Meeting</u>					1992
	M	H.-M. Yang, Y.-C. Huang, T.-F. Lei, C.-L. Lee and S.-C. Chao, "High-resolution MOS Magnetic Sensor with Thin Oxide in Standard Submicron CMOS Process," <u>Sensors and Actuators</u> , Vol. A57					1996
	N	J.W.A. von Kluge and W.A. Langheinrich, "An Analytical Model of MAGFET Sensitivity Including Secondary Effects Using a Continuous Description of the Geometric Correction Factor G," <u>IEEE Transactions on Electron Devices</u> , Vol. 46, No. 1					Jan. 1999
	O	S. Hentschke, "Digital Stochastic Magnetic-Field Detection," <u>Sensors and Actuators</u> , Vol. A57					1996
	P	H.J.M. Veendrick, "The Behavior of Flip-Flops Used as Synchronizers and Prediction of Their Failure Rate," <u>IEEE Journal of Solid-State Circuits</u> , Vol. SC-15, No. 2					April 1980
	Q	A.D. Singh, "Experiments with an On-Chip IDDQ Current Sensor for VLSI Testing," <u>IEEE Int'l Workshop on IDDQ Testing</u>					1995
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